## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Heisley

Docket No.: TI-33886.1

Serial No.: TBD

Examiner:

TBD

Filed:

3/2/2004

Art Unit:

**TBD** 

For:

WAFER ALIGNMENT DEVICE AND METHOD

## **PRELIMINARY AMENDMENT**

Honorable Assistant

Commissioner

of Patents

Washington, D.C. 20231

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Date of Deposit: 3-2-04

Prior to the examination of the above identified application, please amend the above referenced Application as follows: